

Docket No.: 1514.1032

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Ji Yong PARK et al.

Application No. 10/690,507

Group Art Unit: 1792

Confirmation No. 6043

Filed: October 23, 2003

Examiner: Matthew J. Song

For: METHOD FOR MANUFACTURING POLYCRYSTALLINE SILICON THIN FILM AND THIN FILM TRANSISTOR FABRICATED USING POLYCRYSTALLINE SILICON THIN FILM MANUFACTURED BY THE MANUFACTURING METHOD

**RESPONSE IN SUPPORT OF REQUEST FOR CONTINUED EXAMINATION (RCE)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Advisory Action dated on March 19, 2008 and the final Office Action mailed November 26, 2007, and having a period for response set to expire on February 26, 2008. The following remarks and Declaration under Rule 312 are respectfully submitted. Reconsideration of the claims is respectfully requested.